



Docket No. 740756-2654

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Akira ISHIKAWA) Group Art Unit: 2823
Serial No. 10/670,310) Examiner: Lalrinfamkim Malsawma
Filed: September 26, 2003) Confirmation No. 5329
For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE) Date: September 26, 2005

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 24, 2005, please consider the amendments and remarks in connection with the above-identified application as follows.